501924393 05/17/2012

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE

CONVEYING PARTY DATA

Name	Execution Date
Massachusetts Institute of Technology	03/01/2012

RECEIVING PARTY DATA

Name:	National Science Foundation	
Street Address:	4201 Wilson Blvd	
Internal Address:	Room 1265	
City:	Arlington	
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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12990268

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PATENT 501924393 REEL: 028231 FRAME: 0042

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Invention Title: Improved Thermoelectric Figure-of-Merit in Skutterudites
Inventor(s): Gang Chen, Zhifeng Ren, Qing Hao, Jian Yang, Xiao Yang, Qinyu He
U.S. Filing/Issue Date: 4 30 2009
Patent or Application Serial No.: 12/990268
Grant/Contract Number(s): BET0506830, DG-FG02-00ER45805
Foreign Applications filed/intended in (countries):
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PATENT REEL: 028231 FRAME: 0043

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